Application No.	Applicant(s)	
09/655,917	OHMURA, AKIRA	
Examiner	Art Unit	
Kelly L. Jerabek	2612	

SEARCHED				
Class	Subclass	Date	Examiner	
348	207.1	4/19/2005	KJ	
	231.3			
	460			
382	100			
	232	4/20/2005		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
348	231.3	4/20/2005	КJ	
382	100			
382	232			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
IEEE	4/19/2005	КЈ	
EAST Keyword	4/20/2005		